

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Keiji YOSHIMURA) Examiner: Z. E. Cabrera
Application No.: 09/964,648) Group Art Unit: 2125
Filed: September 28, 2001) Confirmation No.: 1952
For: EXPOSURE APPARATUS, SEMICONDUCTOR) October 27, 2006
DEVICE MANUFACTURING METHOD, :
EXPOSURE APPARATUS MAINTENANCE)
METHOD AND SEMICONDUCTOR :
MANUFACTURING FACTORY)

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application as follows: